

Application No.	Applicant(s)	-
10/722,094	AHN ET AL.	
Examiner	Art Unit	
Paul D. Kim	3720	

SEARCHED					
Class	Subclass	Date	Examiner		
29	602.1 604 605 606	12/21/2004	PK		
156	89.11 89.1				
	229				
257	531				
336	176 200				
	229				
438	238 381				
	788 792	W .			
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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	ext Search achment	8/7/2007	РK	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Reviewed Parent applications 09/261,595 10/280,180	12/21/2004	РК		
Text Search EAST/NPL (IEEE)	12/21/2004	PK		
Updated Text Search EAST	1/19/2005	РК		
Updated Text Search EAST	6/27/2005	РК		
Updated Text Search EAST	1/12/2006	РК		
Updated Text Search EAST	4/18/2006	PK		
Updated Text Search EAST	12/7/2006	РК		
Updated Text Search EAST/PGPub	8/7/2007	PK		